

APPLICATION DATA SHEET

Electronic Version 0.0.11

Stylesheet Version: 1.0

Attorney Docket Number: 740756-2641

Publication Filing Type: new-utility

Application Type: utility

Title of Invention: PROCESS FOR PRODUCTION OF SOI SUBSTRATE AND PROCESS FOR PRODUCTION OF SEMICONDUCTOR DEVICE

Suggested Representative Figure: Figs. 1A

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22204

Continuity Data:

This application is a division of 09/907,911 2001-07-19 Pending

which is a division of 09/356,704 1999-07-20 Issued

Foreign Priority:

10-214125

JP 1998-07-29

Priority Claimed

Assignee (Publish): SEMICONDUCTOR ENERGY LABORATORY CO., LTD.

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